



1762

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July 25, 2003

Mail Stop Non-Fee AMENDMENT

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Re: Applicant(s): Woo Sik Yoo  
Assignee: WaferMasters, Inc.  
Title: Method and Apparatus for Forming an Oxide Layer  
Serial No.: 10/085,498  
Examiner: Kirsten Jolley  
Docket No.: M-11549 US

Filed: February 26, 2002  
Group Art Unit: 1762

RECEIVED  
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TC 1700

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter;
- (3) Response to Notice of Restriction Requirement (1 page).

- ☒ No additional fee is required.  
☐ The fee has been calculated as shown below:

## CLAIMS AS AMENDED

	Claims Remaining After Amendment		Highest No. Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	20	Minus	31	=	0	x \$18.00	\$ 0
Independent Claims	2	Minus	5	=	0	x \$84.00	\$ 0
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application							\$
<input type="checkbox"/> Fee for Request for Extension of Time							\$

### Total additional fee for this Amendment:

\$

- ☐ Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
- ☐ Please charge our Deposit Account No. 50-2257 in the amount of \$
- ☒ Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total: \$0

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on July 25, 2003.

Sandy Kim

July 25, 2003

Respectfully submitted,

Theodore P. Lopez  
Attorney for Applicants  
Reg. No. 44,881



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo  
Assignee: WaferMasters, Inc.  
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#7  
Jolley  
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TC 1700

Irvine, California  
July 25, 2003

Mail Stop AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF RESTRICTION REQUIREMENT

Dear Sir:

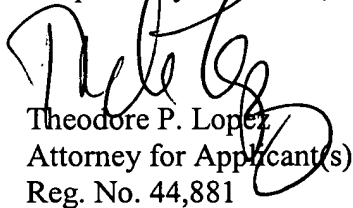
In response to the Restriction Requirement dated June 25, 2003, Applicant(s) hereby elect to prosecute Group I, Claims 1-20. Applicant reserves the right to prosecute non-elected Claims 21-31, in divisional applications. If the Examiner has any questions, please call the undersigned at (949) 752-7040.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on July 25, 2003.

  
Sandy Kim

July 25, 2003  
Date of Signature

Respectfully submitted,

  
Theodore P. Lopez  
Attorney for Applicant(s)  
Reg. No. 44,881

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